



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Patricia B. Smith, et al.

Art Unit: 2818

Serial No.: 09/975,639

Examiner: Quoc D. Hoang

Filed: 10/11/01

Docket: TI-29811

For: HYDROGEN PLASMA PHOTORESIST STRIP AND POLYMERIC RESIDUE CLEANUP PROCESS FOR LOW
DIELECTRIC CONSTANT MATERIALS

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Karen Vertz 7-1-04
Karen Vertz Date

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

EXTENSION OF TIME

Pursuant to 37 CFR 1.136(a), Applicants respectfully petition the Commissioner for an extension of the shortened statutory period for response in the above-identified Application.

The fee for this extension is indicated below:

- First Month (\$110)
- Second Month (\$410)
- Third Month (\$930)
- Fourth Month (\$1,450)
- Fifth Month (\$1,970)

Please charge the fee to deposit account No. 20-0668 of Texas Instruments Incorporated. The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment to Account No. 20-0668. An original and two copies of this sheet are enclosed

Respectfully submitted

Rose Alyssa Keagy
Rose Alyssa Keagy
Registration No. 35,095

Texas Instruments, Incorporated
P. O. Box 655474 - M/S 3999
Patent Department
Dallas, Texas 75265

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